



IFW

PATENT
Customer No. 22,852
Attorney Docket No. 04329.3181

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Kiyotaka MIYANO) Group Art Unit: 2826
)
Application No.: 10/706,034) Examiner: Erdem, Fazli
)
Filed: November 13, 2003)
)
For: SEMICONDUCTOR DEVICE AND)
METHOD OF MANUFACTURING)
THE SAME)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO RESTRICTION REQUIREMENT

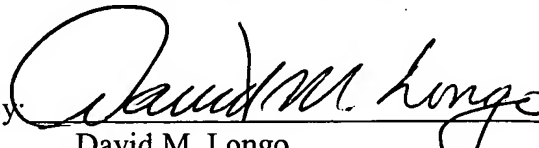
In the Restriction Requirement mailed August 10, 2004, with a period for response extending to September 10, 2004, the Examiner required restriction under 35 U.S.C. § 121 between Group I (claims 1 - 4) and Group II (claims 5 - 20). Applicant provisionally elects to prosecute Group II, claims 5 - 20, characterized by the Examiner as drawn to a method of making a semiconductor device, without traverse.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: September 9, 2004

By: 
David M. Longo
Reg. No. 53,235